

PA-IDC

QUERY CONTROL FORM		RTIS USE ONLY	
Application No. <u>09/712,420</u>	Prepared by <u>BNG</u>	Tracking Number <u>5987798</u>	
Examiner-GAU <u>Culbert-1763</u>	Date <u>9-22-04</u>	Week Date <u>7-26-04</u>	
	No. of queries <u>2</u>	<u>DP</u>	<u>IFW</u>

JACKET

a. Serial No.	f. Foreign Priority	k. Print Claim(s)	p. PTO-1449
b. Applicant(s)	g. Disclaimer	l. Print Fig.	q. PTOL-85b
c. Continuing Data	h. Microfiche Appendix	m. Searched Column	r. Abstract
d. PCT	i. Title	n. PTO-270/328	s. Sheets/Figs
e. Domestic Priority	j. Claims Allowed	o. PTO-892	t. Other

SPECIFICATION

- a. Page Missing
- b. Text Continuity
- c. Holes through Data
- d. Other Missing Text
- e. Illegible Text
- f. Duplicate Text
- g. Brief Description
- h. Sequence Listing
- i. Appendix
- j. Amendments
- k. Other

CLAIMS

- a. Claim(s) Missing
- b. Improper Dependency
- c. Duplicate Numbers
- d. Incorrect Numbering
- e. Index Disagrees
- f. Punctuation
- g. Amendments
- h. Bracketing
- i. Missing Text
- j. Duplicate Text
- k. Other

MESSAGE

① Improper Dependency: in the claim set dated 6-22-04, Claim 15 (renumbered claim 13) is dependent upon a cancelled claim.

② PTO-1449: Please either initial OR line through citation.
Copy provided for reference.

Thank you,
initials BNG

RESPONSE

initials



OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)		
X		Yao et al., "Single Crystal Silicon Supported Thin Film Micro Mirrors for Optical Applications" Opt. Eng. 36(5) 1408-1413 (May 1997)
Y		Conant et al. "A Flat High Frequency Scanning Micromirror" Abstract Submitted to Hilton Head 2000
Z		Storment et al. "Flexible Dry Release Process for Aluminum Electrostatic Actuators" Journal of Microelectromechanical Systems Vol. 3 No. 3 Sept 1994
AA		Mita et al., "An Out-of-Plane Polysilicon Actuator With a Smooth Vertical Mirror for Optical Fiber Switch Application"
AB		Marxer et al. "Vertical Mirrors Fabricated by Deep Reactive Ion Etching For Fiber-Optic Switching Applications" Journal of Microelectromechanical Systems, Vol. 6 No. 3, Sept 1997
AC		Fedder, G.K., "integrated microelectromechanical systems in conventional CMOS", Proceedings of 1997 IEEE International Symposium on Circuits and Systems. Circuits and Systems in the Information Age. ISCAS '97 (Cat. No. 97CH35987), pages 2821-2824, vol. 4
EXAMINER		DATE CONSIDERED
Robert Gehret		10/27/02
* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		